**PATENT** 

Attorney Docket No.: SSI-04001

THE THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

William Dale Jones

Serial No.: 10/680,783

Filed: October 6, 2003

For: HIGH-PRESSURE PROCESSING

CHAMBER FOR A

SEMICONDUCTOR WAFER

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Group Art Unit: 1763

Examiner: Lund, Jeffrie Robert

Response to Office Action mailed on September 29, 2005

162 N. Wolfe Road Sunnyvale, CA 94086

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The Applicant submits this response to the Office Action mailed on September 29, 2005:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.

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